

MICRON.230DV1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Liu et al.  
Appl. No. : 10/734,663  
Filed : December 11, 2003  
For : METHOD FOR MANUFACTURE  
OF MAGNETO-RESISTIVE BIT  
STRUCTURE  
Examiner : Long K. Tran  
Group Art Unit : 2818

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

December 20, 2005  
(Date)

Adcel S. Akhtar  
Adcel S. Akhtar, Reg. No. 41,394

AMENDMENT UNDER 37 C.F.R. 1.312

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The present amendment under 37 C.F.R. § 1.312 is filed after the issuance of the Notice of Allowance in connection with the above-identified patent application and with payment of the issue fee. Please amend the above-identified application as indicated below.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Drawings** begin on page 4 of this paper. Replacement sheets are also attached to this paper.

**Remarks/Arguments** begin on page 5 of this paper.